Electronic Patent Application Fee Transmittal							
Application Number:		10769820					
Filing Date:	03-	03-Feb-2004					
Title of Invention:	IRF	LASER IRRADIATION STAGE, LASER IRRADIATION OPTICAL SYSTEM, LASER IRRADIATION APPARATUS, LASER IRRADIATION METHOD, AND METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE					
First Named Inventor/Applicant Name:	Ко	Koichiro Tanaka					
Filer:	Jef	Jeffrey Costellia/Carmela Beverly					
Attorney Docket Number:	740	740756-2709					
Filed as Large Entity	•						
Utility under 35 USC 111(a) Filing Fees							
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)		
Basic Filing:							
Pages:							
Claims:							
Miscellaneous-Filing:							
Petition:							
Patent-Appeals-and-Interference:							
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Utility Appl issue fee		1501	1	1510	1510		
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Extension-of-Time:							
Miscellaneous:							
Printed copy of patent - no color	8001	3	3	9			
	Tot	(\$)	1819				